

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Patricia B. SMITH et al. Confirmation No.: 3087  
Application Number : 10/647,985  
Filed : August 26, 2003  
Title : POST-ETCH CLEAN PROCESS FOR POROUS LOW  
DIELECTRIC CONSTANT MATERIALS  
TC/Art Unit : 1792  
Examiner: : Eric Wayne Golightly  
  
Docket No. : TI-33260 (0025.0184)  
Customer No. : **23494**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REPLY TO OFFICE ACTION UNDER 37 CFR §1.111**

Please enter the following in response to the Office Action mailed

August 28, 2008:

**A listing the Claims** is reflected in the listing of claims in this paper starting on  
page 2.

**Remarks/Arguments** follow the amendment sections of this paper starting on  
page 7.